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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Inventor(s): Stephen P. DeOrnellas et al.
SC/Serial No.: 10/045,318
Confirm. No.: 3120
Filed: November 9, 2001
Title: METHOD FOR USING A HARD
MASK FOR CRITICAL
DIMENSION GROWTH
CONTAINMENT

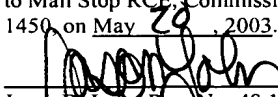
PATENT APPLICATION

Art Unit: 1765
Examiner: L. Umez-Eronini

Customer No. 23910

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop RCE, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on May 29, 2003.



Jason D. Lohr, Reg. No. 48,163
Signature Date: May 29, 2003

(Attorney Signature)

RESPONSE "B" TO OFFICE ACTION UNDER 37 C.F.R. § 1.116

Mail Stop RCE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This RESPONSE B is in reply to the Office action mailed November 22, 2002. No fee is due for the addition of new claims. An appropriate Petition for Extension of Time to Respond is submitted herewith, together with the appropriate fee.

Amendments

Please amend the above-identified application as follows: